



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Confirmation No. 9958

Masamichi NAKASHIBA et al.

Docket No. 2000-0722

Serial No. 09/589,388

Group Art Unit 3723

Filed June 8, 2000

Examiner George Nguyen

APPARATUS FOR AND METHOD FOR  
POLISHING WORKPIECE

TECHNOLOGY CENTER R3700

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AUG 05 2003

AMENDMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action of January 31, 2003, the period for response to which having been extended by three months to July 31, 2003, kindly amend the above-referenced U.S. patent application as follows:

IN THE SPECIFICATION

Please insert before BACKGROUND OF THE INVENTION in column 1 and after the title the following:

REFERENCE TO RELATED APPLICATION

A continuation of this reissue application was filed May 13, 2002 and bears Serial No. 10/142,980.

IN THE CLAIMS

12. (Amended) A method of polishing a surface of a workpiece, comprising:  
holding a workpiece by a top ring; and